



Docket No. 740756-2650

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Hidekazu MIYAIRI et al.	)	Group Art Unit: 2828
Serial No. 10/658,472	)	Examiner: Phillip Nguyen
Filed: September 10, 2003	)	Confirmation No. 4070
For: LASER APPARATUS, LASER IRRADIATION	)	
METHOD, AND MANUFACTURING ...	)	

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 14, 2006, please amend the above identified application as follows.